

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

Title of Invention

INCREASE PRODUCTIVITY AT WAFER TEST USING PROBE
RETEST DATA ANALYSIS

Application Number :

Confirmation Number:

First Named Applicant: Akiko Balchiunas

Attorney Docket Number: BUR920040137US1

Art Unit:

Examiner:

Search string: (6240329 or 6350959 or 6507800 or 6618682 or 20030120445 or 20030139839
.pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

| init | Cite.No. | Patent No. | Date | Patentee | Kind | Class | Subclass |
|------|----------|------------|------------|---------------|------|-------|----------|
| | 1 | 6240329 | 2001-05-29 | Sun | | | |
| | 2 | 6350959 | 2002-02-26 | Beffa | | | |
| | 3 | 6507800 | 2003-01-14 | Sheu | | | |
| | 4 | 6618682 | 2003-08-09 | Bulaga et al. | | | |

US Published Applications

Note: Applicant is not required to submit a paper copy of cited US Published Applications

| init | Cite.No. | Pub. No. | Date | Applicant | Kind | Class | Subclass |
|------|----------|-------------|------------|----------------|------|-------|----------|
| | 1 | 20030120445 | 2003-06-26 | Barbour et al. | | | |
| | 2 | 20030139839 | 2003-07-24 | Beffa | | | |

Signature

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|---------------|------|
| Examiner Name | Date |
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